

## AMENDMENTS

### In the Specification:

Amend the Title to read METHOD OF MANUFACTURING SEMICONDUCTOR  
DEVICE AND MANUFACTURING METHOD THEREOF.

Page 1, after the title, insert the following:

### Reference to the Related Application:

This application is a division of Serial No. 10/215,188, filed August 9, 2002, now U.S.

Patent No. \_\_\_\_\_.